Application/Control No. Applicant(s)/Patent Under Reexamination O9/469,206 Applicant(s)/Patent Under Reexamination

Notice of References Cited

D9/469,206

PUGACZEWSKI ET AL.

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-6,307,836	10-2001	Jones et al.	370/230
	В	US-6,377,554	04-2002	Farnsworth et al.	370/252
	С	US-6,292,834	09-2001	Ravi et al.	709/233
*	D	US-5,953,338	09-1999	Ma et al.	370/395.21
	E	US-6,075,792	06-2000	Ozluturk, Fatih M.	370/441
	F	US-6,118,780	09-2000	Dunn et al.	370/355
	G	US-6,122,287	09-2000	Ohanian et al.	370/465
	Н	US-6,301,267	10-2001	Ben-Ami, Raphael	370/468
	ł	US-6,385,169	05-2002	Wang, Zheng	370/230
	J	US-5,732,078	03-1998	Arango, Mauricio	370/355
	К	US-6,438,141	08-2002	Hanko et al.	370/477
	L	US-6,404,738	06-2002	Reininger et al.	370/236
	М	US-6,389,010	05-2002	Kubler et al.	370/353

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.